

Title (en)
PROCESS FOR THE MANUFACTURE OF A HIGHLY -g(e) DIELECTRIC OR FERROELECTRIC COATING

Title (de)
HERSTELLVERFAHREN FÜR EINE HOCH--g(e)-DIELEKTRISCHE ODER FERROELEKTRISCHE SCHICHT

Title (fr)
PROCEDE DE FABRICATION D'UNE COUCHE HAUTEMENT -g(e)-DIELECTRIQUE OU FERROELECTRIQUE

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Application
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Abstract (en)
[origin: DE19640241C1] The invention concerns a multi-step process. Stage one consists of sputtering the coating at a low temperature. Stage two involves application of an RTP process in an inert atmosphere at a medium or high temperature. In stage three the coating is tempered in an atmosphere containing oxygen at a low or medium temperature. Temperature load is significantly reduced in comparison with conventional processes so that when this process is used to produce an integrated memory cell oxidation of an underlying barrier coating can be prevented.

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IPC 8 full level
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